

Publications for Annie Ross

2016

Ganesan, R., Treverrow, B., Murdoch, B., Xie, D., Ross, A., Partridge, J., Falconer, I., McCulloch, D., McKenzie, D., Bilek, M. (2016). Duty cycle control in reactive high-power impulse magnetron sputtering of hafnium and niobium. *Journal of Physics D: Applied Physics*, 49(24), 1-11. [More Information]

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Ross, A., McKenzie, D. (2016). Predator-prey dynamics stabilised by nonlinearity explain oscillations in dust-forming plasmas. *Scientific Reports*, 6, 1-9. [More Information]

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Ross, A., Ganesan, R., Bilek, M., McKenzie, D. (2015). A feedback model of magnetron sputtering plasmas in HIPIMS. *Plasma Sources Science and Technology*, 24(2), 1-11. [More Information]

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Adams, M., Brown, C., Duston, T., Gohil, K., Horner, M., Kotary, K., Naish, G., Schwarz, R., Varanasi, P., Weeks, A. (2010). Device for dispensing volatile liquids and corresponding container. *Patent No. 1613363B1*.

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